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CONFIRMATION NO. 7268

| SERIAL NUMBER | FILING or 371(c) DATE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. | | |
|---|---|--|---------------------------------|--|--------------|--------------------|
| 10/567,904 | 08/29/2006 RULE | 250 | 4174 | 286249US2PCT | | |
| APPLICANTS Dai Kobayashi, Tokyo, JAPAN; Hideki Kawakatsu, Tokyo, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/11351 08/06/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-290989 08/11/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/24/2007 | | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY | SHEETS DRAWINGS | TOTAL CLAIMS | INDEPENDENT CLAIMS |
| Verified and /BROOKE J PURINTON/ | Acknowledged Examiner's Signature | Initials | JAPAN | 22 | 11 | 2 |
| ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES | | | | | | |
| TITLE Probe for probe microscope using transparent substrate, method of producing the same, and probe microscope device | | | | | | |
| FILING FEE RECEIVED 1440 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees | | |
| | | | | <input type="checkbox"/> 1.16 Fees (Filing) | | |
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